



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,320  
Filing Date July 13, 2001  
Inventorship Cem Basceri et al.  
Assignee Micron Technology, Inc.  
Group Art Unit 1762  
Examiner Eric B. Fuller  
Attorney's Docket No. MI22-1657  
Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate  
Comprising Dielectric Layers, Including Such Layers Having a Varied  
Concentration of Barium and Strontium Within the Layer

**RESPONSE TO OCTOBER 3, 2002 OFFICE ACTION**

To: Assistant Commissioner for Patents  
Attn: Art Unit 1762  
Washington, D.C. 20231

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Responsive to the October 3, 2002 Office Action, Applicant remarks as follows.

**AMENDMENTS**

None.